

H.S.B.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoru MIYASHITA, Hiroshi KIGUCHI, Tatsuya SHIMODA and Sadao KANBE

Application No.: New Rule 1.53(b) Divisional of U.S.S.N. 09/101,083

Filed: July 10, 2001

Docket No.: 101050.02

For: METHOD OF MANUFACTURING ORGANIC EL ELEMENT, ORGANIC EL ELEMENT, AND ORGANIC EL DISPLAY DEVICE

PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 1-24 without prejudice to or disclaimer of the subject matter contained therein.

Please add new claims 25-75 as follows:

--25. A process for forming a pattern on a substrate by deposition of an organic material comprising the steps of:

depositing a semiconducting organic material in a solvent onto a substrate by ink-jet printing; and

evaporating the solvent, whereby said organic material remains on the substrate.--

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